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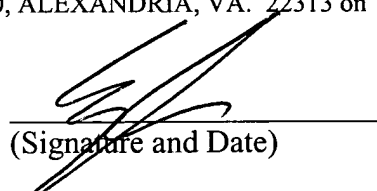
IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

APPLICANT : Young-Churl Bang et al.  
SERIAL NO. : 10/805,790 EXAMINER : Jarrett J. Stark  
FILED : March 22, 2005 ART UNIT : 2823  
FOR : METHOD OF GROWING SELECTIVE AREA BY METAL ORGANIC  
CHEMICAL VAPOR DEPOSITION

Certificate of Mailing Under 37 CFR 1.8

I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail in an envelope addressed to MAIL STOP AMENDMENT, COMMISSIONER FOR PATENTS, P.O. BOX 1450, ALEXANDRIA, VA. 22313 on March 31, 2006.

Steve Cha, Reg. No. 44,069  
(Name of Registered Rep.)

  
(Signature and Date)

RESPONSE TO REQUIREMENT FOR RESTRICTION  
UNDER 35 U.S.C. §121

MAIL STOP AMENDMENT  
COMMISSIONER FOR PATENTS  
P.O. BOX 1450  
ALEXANDRIA, VA. 22313

Dear Sir:

Responsive to the Office Action dated March 1, 2006, issued in connection with the above-identified Application, which is now due for response on April 1, 2006, please consider the following remarks.